

11/02/01  
10004345  
2005/02

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10004345	11/02/2001	315 115	20115	2017	2313 N. HARRIS

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\*\*CONTINUING DATA VERIFIED: *DA*  
*None*

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\*\* FOREIGN APPLICATIONS VERIFIED: *DA*  
JAPAN 2000-347,735 11/15/2000

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO
35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		782_193
Verified and Acknowledged Examiners's initials <i>DA</i>		
TITLE : Method for fabricating a III-V nitride film and an apparatus for fabricating the same		

U.S. DEPT. OF COMM./PAT & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
			Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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